

# Semiconductor gas sensors

Edited by Raivo Jaaniso and Ooi Kiang Tan



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Published by Woodhead Publishing Limited, 80 High Street, Sawston, Cambridge CB22 3HJ, UK www.woodheadpublishing.com www.woodheadpublishingonline.com

Woodhead Publishing, 1518 Walnut Street, Suite 1100, Philadelphia, PA 19102-3406, USA

Woodhead Publishing India Private Limited, 303 Vardaan House, 7/28 Ansari Road, Daryaganj, New Delhi - 110002, India www.woodheadpublishingindia.com

First published 2013, Woodhead Publishing Limited

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British Library Cataloguing in Publication Data

A catalogue record for this book is available from the British Library.

Library of Congress Control Number: 2013942858

ISBN 978-0-85709-236-6 (print) ISBN 978-0-85709-866-5 (online)

ISSN 2050-1501 Woodhead Publishing Series in Electronic and Optical Materials (print) ISSN 2050-151X Woodhead Publishing Series in Electronic and Optical Materials (online)

The publisher's policy is to use permanent paper from mills that operate a sustainable forestry policy, and which has been manufactured from pulp which is processed using acid-free and elemental chlorine-free practices. Furthermore, the publisher ensures that the text paper and cover board used have met acceptable environmental accreditation standards.

Typeset by Newgen Knowledge Works Pvt Ltd, India Printed by Lightning Source

### Semiconductor gas sensors

### Contributor contact details

(\* = main contact)

#### **Editors**

R. Jaaniso Institute of Physics University of Tartu Tartu 51014 Estonia

E-mail: raivo.jaaniso@ut.ee

O. K. Tan School of Electrical & Electronic Engineering Nanyang Technological University S1-B1a-06, 50 Nanyang Avenue Singapore 639798

E-mail: EOKTAN@ntu.edu.sg

### Chapter 1

N. Yamazoe\* and K. Shimanoe Faculty of Engineering Sciences Kyusyu University Japan 6–1 Kasuga-koen Kasuga Fukuoka 816–8580 Japan

Email: noboru.yamazoe.510@m. kyushu-u.ac.jp; shimanoe. kengo.695@m.kyushu-u.ac.jp

#### Chapter 2

N. Bârsan\*, M. Huebner and U. Weimar Faculty of Science Institute of Physical Chemistry University of Tübingen Auf der Morgenstelle 15 72076 Tuebingen Germany

E-mail: nb@ipc.uni-tuebingen.de

### Chapter 3

S. P. Lee
Department of Electronic
Engineering
Kyungnam University
449 Wolyong dong
Masanhappogu
Changwon
Kyungnam 631–701
Republic of Korea

E-mail: sensors@kyungnam.ac.kr

### Chapter 4

M. Andersson and A. Lloyd Spetz\*
 Division of Applied Sensor Science
 Department of Physics, Chemistry and Biology
 Linköping University
 SE-581 83

Linköping Sweden

E-mail: mikan@ifm.liu.se; spetz@ ifm.liu.se

R. Pearce
National Physical Laboratory
Hampton Road
Teddington
Middlesex
TW11 0LW
United Kingdom

E-mail: ruth.pearce@npl.co.uk

### Chapter 5

F. Ren and S. J. Pearton\*
Department of Chemical
Engineering
University of Florida
Gainesville
FL 32611
USA

Email: ren@che.ufl.edu; spear@mse.ufl.edu

### Chapter 6

D. Briand\*
Ecole Polytechnique Fédérale de
Lausanne (EPFL)
Institute of Microengineering
(IMT)
Sensors, Actuators and
Microsystems Laboratory
(SAMLAB)
Maladière 71b 2000 Neuchâtel
Switzerland
E-mail: danick.briand@epfl.ch

J. Courbat
Innovative Sensor Technology IST
AG
Stegrütistrasse 14
CH-9642 Ebnat-Kappel
Switzerland

E-mail: jerome.courbat@ist-ag.com

### Chapter 7

F. Rettig and R. Moos\*
University of Bayreuth
Department of Functional
Materials
95440 Bayreuth
Germany

E-mail: Functional.Materials@ Uni-Bayreuth.de

### Chapter 8

E. Comini
SENSOR
Department of Information
Engineering
Brescia University and CNRIDASC
via valotti 9
25133 Brescia
Italy

E-mail: comini@ing.unibs.it

### Chapter 9

Z. Zhao and M. A. Carpenter\*
College of Nanoscale Science and Engineering
University at Albany – State University of New York
257 Fuller Road
Albany NY 12203 USA

E-mail: mcarpenter@albany.edu; zzhao@albany.edu

M. A. Petrukhina
Department of Chemistry
University at Albany – State
University of New York
1400 Washington Avenue
Albany
NY 12222
USA

E-mail: mpetrukhina@albany.edu

### Chapter 10

Y. Battie\*
LCP-A2MC (EA4632)
Université de Lorraine
1 Boulevard Dominique François
Arago
57070 Metz Technopôle
France

E-mail: yann.battie@univ-lorraine.fr

O. Ducloux ONERA 29 Avenue de la division Leclerc 92322 Chatillon France

E-mail: Olivier.ducloux@onera.fr

### Chapter 11

T. Kerdcharoen\*
Department of Physics
Faculty of Science
Mahidol University
272 Rama 6 Road
Ratchathewi
Bangkok 10400
Thailand

and

NANOTEC Center of Excellence at Mahidol University National Nanotechnology Center Thailand

E-mail: sctkc@mahidol.ac.th

C. Wongchoosuk
Department of Physics
Faculty of Science
Kasetsart University
50 Phahon Yothin Road
Chatuchak
Bangkok 10900
Thailand

E-mail: chatchawal.w@ku.ac.th

### Chapter 12

V. M. Aroutiounian
Department of Physics
of Semiconductors and
Microelectronics
Yerevan State University
1 Alex Manoukian
Yerevan 0025
Armenia

E-mail: aroutiounv1@yahoo.com

### Chapter 13

R. Binions\*
School of Engineering and
Materials Science
Queen Mary, University of London
Mile End Road
London
E1 4NS
United Kingdom

E-mail: r.binions@qmul.ac.uk

A. J. T. Naik

Department of Chemistry
University College London
Christopher Ingold Laboratories
20 Gordon Street
London
WC1H 0AJ
United Kingdom

E-mail: a.naik@ucl.ac.uk

### Chapter 14

D.-D. Lee\* School of Electronics Engineering Kyungpook National University Daegu 702–701 Korea

E-mail: ddlee@ee.knu.ac.kr

J.-C. Kim
Department of Chemical
Engineering
Kyungpook National University
Daegu 702–701
Korea

E-mail: kjchang@knu.ac.kr

### Chapter 15

P. K. Guha\*
Electronics and Electrical
Communication Engineering
Department
Indian Institute of Technology
Kharagpur
India-721302

E-mail: pkguha@ece.iitkgp.ernet.in

S. Santra
Physics and Meteorology
Department
Indian Institute of Technology
Kharagpur
India-721302

E-mail: sumita.santra@gmail.com

J. W. Gardner
Microsensors and Bioelectronics
Laboratory
School of Engineering
University of Warwick
Coventry CV4 7AL
UK

E-mail: J.W.Gardner@warwick. ac.uk

### Chapter 16

G. G. Mandayo\*
CEIT and Tecnun
University of Navarra
P. Manuel Lardizabal 15
20018 San Sebastian
Spain

E-mail: ggmandayo@ceit.es; ggmandayo@tecnun.es

J. Herrán CIDETEC-IK4 P° Miramón 196 2009 San Sebastian Spain

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